

L Number	Hits	Search Text	DB	Time stamp
1	1	5862275.pn.	USPAT	2003/04/19 17:06
2	0	5862275.pn. and photolithography	USPAT	2003/04/19 17:29
3	0	5862275.pn. and etching	USPAT	2003/04/19 17:06
4	24	actuator with photolithography	USPAT	2003/04/19 17:11
5	0	optical near2 actuator with photolithography	USPAT	2003/04/19 17:12
6	989	photolithography with cvd	USPAT	2003/04/19 17:13
7	300	( photolithography with cvd) and optic\$2	USPAT	2003/04/19 17:14
8	229	mold\$3 with photolithography	USPAT	2003/04/19 17:14
9	169	(mold\$3 with photolithography) and etching	USPAT	2003/04/19 17:14
10	101	((mold\$3 with photolithography) and etching) and (actuator\$1 or switch\$3)	USPAT	2003/04/19 17:22
11	0	6a56243.pn.	USPAT	2003/04/19 17:22
12	1	6156243.pn.	USPAT	2003/04/19 17:22
13	0	6156243.pn. and photolithography	USPAT	2003/04/19 17:22
14	1	6156243.pn. and etching	USPAT	2003/04/19 17:29
15	0	photolithography same planarizing same (sacrifice adj1 layer) same etching	USPAT	2003/04/19 17:34
16	227	photolithography same planarizing	USPAT	2003/04/19 17:37
17	189	(photolithography same planarizing) and etching	USPAT	2003/04/19 17:38
18	1	((photolithography same planarizing) and etching) and (sacrifice adj1 layer)	USPAT	2003/04/19 17:38
19	2125	photolithography and planarizing	USPAT	2003/04/19 17:39
20	1867	(photolithography and planarizing) and etching	USPAT	2003/04/19 17:38
21	2	((photolithography and planarizing) and etching) and (sacrifice adj1 layer)	USPAT	2003/04/19 17:38
22	29849	photolithography	USPAT	2003/04/19 17:40
23	21	photolithography same (sacrifice adj1 layer)	USPAT	2003/04/19 17:44